


**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT PTO-1449**

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| Docket No. | Application No. | |
| 52433/830 | 10/561,133 | |
| Applicant(s) | Examiner | |
| Natsuko SUGIURA, et al. | Deborah YEE | |
| Filing Date | Confirmation No. | Art Unit |
| December 15, 2005 | 6256 | 1793 |

U. S. PATENT DOCUMENTS

| EXAMINER INITIAL | PATENT/PUBLICATION NUMBER | PATENT/PUBLICATION DATE mm/dd/yyyy | NAME | CLASS | SUBCLASS | FILING DATE* |
|------------------|---------------------------|---------------------------------------|------|-------|----------|--------------|
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FOREIGN PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | DATE mm/dd/yyyy | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
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| EXAMINER INITIAL | AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC. |
| | Chinese Patent issued March 12, 2008 in corresponding Chinese Patent Application No.: CN 200480017463.3 |
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| EXAMINER | DATE CONSIDERED |
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| EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |